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## BIB DATA SHEET

CONFIRMATION NO. 9732

<b>SERIAL NUMBER</b> 10/583,348	<b>FILING or 371(c) DATE</b> 04/05/2007 <b>RULE</b>	<b>CLASS</b> 427	<b>GROUP ART UNIT</b> 1714	<b>ATTORNEY DOCKET NO.</b> 1343.46195X00	
<b>APPLICANTS</b> Yoshitaka Nishio, Osaka, JAPAN; Yukio Oshima, Osaka, JAPAN; <b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP04/18817 12/16/2004 <b>** FOREIGN APPLICATIONS *****</b> JAPAN 2003-436719 12/19/2003 <b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 08/28/2007					
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /NATASHA N. CAMPBELL/ Acknowledged Examiner's Signature	<input type="checkbox"/> Met after Allowance Initials	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWINGS</b> 13	<b>TOTAL CLAIMS</b> 20	<b>INDEPENDENT CLAIMS</b> 4
<b>ADDRESS</b> ANTONELLI, TERRY, STOUT & KRAUS, LLP 1300 NORTH SEVENTEENTH STREET SUITE 1800 ARLINGTON, VA 22209-3873 UNITED STATES					
<b>TITLE</b> Method for Removing Deposit from Substrate and Method for Drying Substrate, as Well as Apparatus for Removing Deposit from Substrate and Apparatus for Drying Substrate Using These Methods					
<b>FILING FEE RECEIVED</b> 1230	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		